

PHOTONICS Research

Ultrasmall and ultradense InGaN-based RGB monochromatic micro-light-emitting diode arrays by pixilation of conductive p-GaN

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We describe 5 μm squircle InGaN-based red, green, and blue (RGB) monochromatic micro-light-emitting diodes (μLEDs) with an interpitch of 4 μm by pixilation of conductive p-GaN using a H_2 -plasma treatment. The p-GaN was passivated by H_2 plasma and prevented the current's injection into the InGaN quantum wells below. We observed that InGaN-based red μLEDs exhibited a broader full width at half-maximum and larger peak wavelength blueshift at 11.5–115 A/cm^2 than the green/blue μLEDs . The on-wafer light output power density of the red μLEDs at a wavelength of 632 nm at 115 A/cm^2 was approximately 936 mW/cm^2 , the highest value reported thus far for InGaN-based red μLEDs . This value was comparable with that of the green/blue μLEDs at 11.5 A/cm^2 , indicating that the red μLEDs can satisfy the requirement of high brightness levels for specific displays. The color gamut based on InGaN RGB μLEDs covered 83.7% to 75.9% of the Rec. 2020 color space in the CIE 1931 diagram at 11.5 to 115 A/cm^2 . © 2021 Chinese Laser Press

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1. INTRODUCTION

Owing to their high efficiency, brightness, and stability, InGaN-based micro-light-emitting diodes (μLEDs) have been considered as core devices in next-generation displays for a wide variety of applications, e.g., wall displays/televisions, smartphones/watches, head-up displays, pico-projectors, and augmented-reality (AR) glasses [1–3]. The full-color μLED displays require integration of red, green, and blue (RGB) μLEDs (R: AlGaInP; G and B: InGaN) on the same panel by pick-and-place technologies. However, the different material systems might cause mismatched far-field radiation patterns for RGB μLEDs [4], leading to a negative visual experience.

Most importantly, the high surface recombination velocities and long carrier diffusion lengths for AlGaInP materials will drastically reduce the efficiency of red μLEDs when the μLED dimensions shrink below 25 μm [5–7]. As a result, InGaN is gathering growing interest as an alternative red μLED candidate.

Despite the good performance of green/blue μLEDs , InGaN-based red μLEDs require an increase in the In-content in InGaN quantum wells (QWs), which will cause significant reduction in efficiency due to the degraded crystal quality of high-In-content InGaN QWs [8]. To solve this problem, special substrates/templates were proposed for high-In-content

InGaN growth, such as InGaInNOS [9], ScAlMgO_4 (0001) [10], and porous GaN [11]. Our group grows high-In-content InGaN QWs by micro-flow-channel metalorganic vapor-phase epitaxy (MOVPE) [12] on sapphire substrates, and the red μLEDs [13] exhibited good efficiencies compared with other works [9,11]. However, the large blueshift of the peak wavelength for InGaN red μLEDs will make them look yellow or orange at high current densities, which cannot satisfy the requirement of the high dynamic operation range for micro-displays (like seamless AR glasses). Therefore, developing InGaN red μLEDs that operate in a high dynamic current density range is necessary.

Besides, ultrasmall ($<10 \mu\text{m}$) InGaN μLEDs are usually fabricated by mesa etching, which physically removes the nitride materials and defines the dimensions of μLEDs [14,15]. This method is the most popular pixilation technique but introduces sidewall damage and reduces device efficiencies [16–18]. Although it is possible to remove damage by chemical etching [19], the efficiencies of InGaN green/blue μLEDs still decrease as the dimension shrinks below 10 μm [20]. Meanwhile, ultra-small ($<10 \mu\text{m}$) red μLEDs are seldom reported for both InGaN and AlGaInP materials [11].

To avoid the drawbacks of mesa etching, the research group from Samsung Ltd. proposed a new pixilation strategy [21] in which it tailored ion implantation to fabricate pixilated InGaN

μ LEDs and demonstrated high (2000–5000) pixels per inch (PPI) μ LED displays with monolithically integrated thin-film transistor pixel circuits. However, this tailored ion implantation should be precisely controlled, which complicates the fabrication process. A simple strategy is more favorable for this kind of pixilation process.

In this work, we describe 5 μ m squircle InGaN-based RGB monochromatic μ LEDs with an interpitch of 4 μ m using H_2 -plasma treatment for pixilation of conductive p-GaN. We examined the current-voltage curves to investigate the passivated p-GaN contacts and the electrical performances of the RGB μ LEDs. The electroluminescence (EL) properties of the RGB monochromatic μ LEDs, such as spectra and light output power (LOP), were investigated. Finally, we evaluated the uniformity and distinctiveness of the RGB μ LEDs qualitatively and determined their color gamut in the CIE 1931 diagram.

2. EXPERIMENTAL DETAILS

InGaN-based red LED epitaxial wafers were grown on *c*-plane patterned sapphire substrates by MOVPE. Our previous work reported the epitaxial structures, which utilized the thick GaN template [22], hybrid InGaN QWs [23], and AlN/AlGaIn hybrid barrier layers [24]. These epi-structures were designed to adjust strain, which helps to improve the crystal quality of InGaN red QWs. The n-type layer in our red LED structure is $n\text{-Al}_{0.03}\text{Ga}_{0.97}\text{N}$, which could realize extremely low resistivity by high Si doping [25]. The growth parameters were similar to those of our previous work [22], but we adjusted the growth temperature for high-In-content InGaN red QWs. The InGaN-based green/blue LED epitaxial wafers were purchased from a commercial supplier. The green/blue commercial epi-wafers can guarantee uniformity and are also suitable to be regarded as the reference samples because they are available for all research groups. Note that the n-type layer in the commercial green/blue LED structures is n-GaN.

The schematic of fabrication processes via pixilation of the conductive p-GaN is shown in Fig. 1. The indium tin oxide (ITO) micro-pillars arrays (20×20) were fabricated by standard lithography and a lift-off process in sequence [Fig. 1(a)]. The micro-pillars were squircle, with a width of 5 μ m. The

average area of the single 5 μ m squircle was 21.66 μm^2 . The interpitch between the adjacent ITO micro-pillars was 4 μ m. The ohmic contacts between ITO micro-pillars and p-GaN were formed by the rapid two-step annealing process [26]. Then, the exposed p-GaN areas were treated with H_2 plasma at 300°C for 2 min. Due to the high-temperature treatment, the H atoms would be not only captured by the p-GaN surface but also diffuse inside the p-GaN layer [27,28]. As a result, the H atoms were bonded to the p-type dopant Mg atoms and passivated the exposed p-GaN, as shown in Fig. 1(b). Finally, an additional ITO layer was used to connect all ITO micro-pillars and the Cr/Au served as the n- and p-electrodes [Fig. 1(c)]. To improve transparency and conductivity of this additional ITO layer, we carried out a two-step rapid annealing process before depositing Cr/Au electrodes. We also fabricated blue LEDs without ITO micro-pillars for comparison. The blue LEDs underwent the same processes in Figs. 1(b) and 1(c) to investigate the current injection of the passivated p-GaN areas.

The InGaN-based RGB monochromatic μ LEDs were characterized at a probe station using a semiconductor parameter analyzer at room temperature. The EL properties were measured by the on-wafer testing, which had a similar configuration to the previous work [29]. A CCD camera installed on the microscope at the probe station was used to capture the emission patterns of these RGB monochromatic μ LEDs.

3. RESULTS AND DISCUSSION

We first examined the contacts between the passivated p-GaN and the ITO layer. The absolute current of the blue LED with the passivated p-GaN was measured under the applied voltage from -4 to 8 V, as shown in Fig. 2. The measured current of the blue LED was less than 1 μA even at the forward bias of 8 V, demonstrating the typical Schottky contact between the passivated p-GaN and the ITO layer. Therefore, we could realize the μ LEDs by the pixilation of the conductive p-GaN, as explained in Fig. 1.

The absolute current-voltage ($|I| - V$) curves of the InGaN RGB monochromatic μ LED arrays (20×20) are plotted in Fig. 2 under the different applied voltages. The absolute

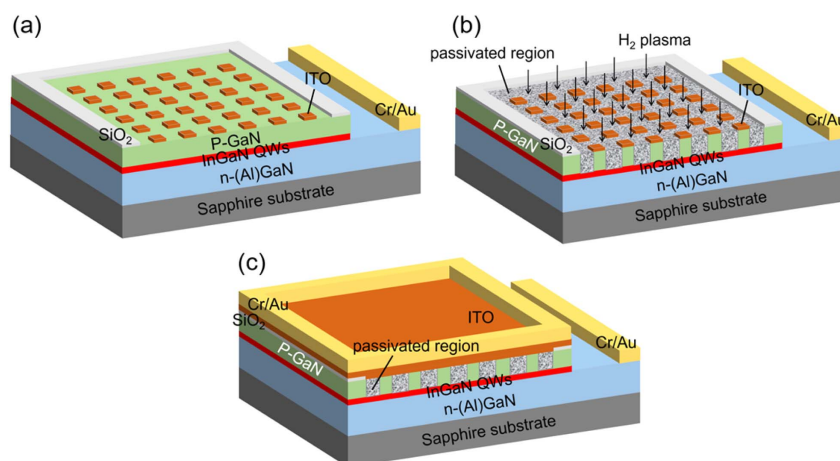


Fig. 1. Schematics of fabrication processes for InGaN-based RGB monochromatic μ LEDs by pixilation of conductive p-GaN.

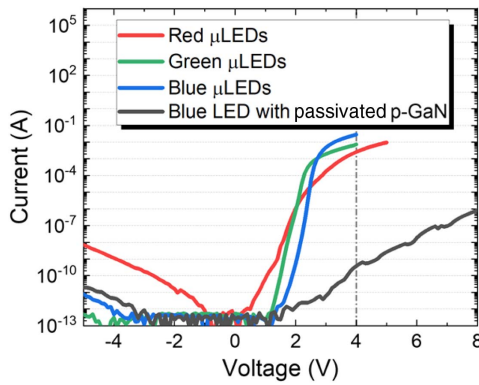


Fig. 2. $|I| - V$ curves of InGaN-based RGB μ LEDs and the blue LED with passivated p-GaN.

current is plotted on a logarithmic scale. At the forward voltage, the $|I| - V$ characteristics of RGB monochromatic μ LEDs exhibited similar behavior. The curves could be separated into two linear parts with different slopes on the semi-logarithmic scale. The two linear parts of the $|I| - V$ curves in forward bias were the same as that of the μ LEDs by mesa etching [13,29]. The turn-on voltage, usually defined as the transition point between the two linear parts, was between 2.0 and 3.0 V for these RGB monochromatic μ LEDs. The green μ LEDs exhibited the lowest turn-on voltage compared with the blue and red μ LEDs.

In addition, we noticed that the currents at 4 V for the RGB μ LEDs were above 10^{-3} A, more than six orders of magnitude larger than that for the blue LED with passivated p-GaN. This result further illustrates that the current could only pass through the activated p-GaN areas covered by ITO micro-pillars for the RGB monochromatic μ LED arrays. As a result, we could calculate the current density by using the measured currents divided by the ITO micro-pillar area. At around 12 A/cm^2 , the forward voltage of RGB monochromatic μ LED arrays was around 3.6, 2.7, and 2.7 V, respectively.

At the reverse voltage, the reverse current remained constant for green/blue monochromatic μ LEDs. However, the reverse current for the red μ LEDs increased after the reverse voltage was above -1 V . This reverse current increase implied that some leakage channels existed in the InGaN red μ LEDs, presumably caused by defects in the InGaN QWs [30].

Figure 3(a) shows the EL spectra of the RGB monochromatic μ LEDs at 11.5 to 115 A/cm^2 . The EL spectra of the red μ LEDs were multiplied by tenfold in the figure. We observed that all EL spectra of the green/blue monochromatic μ LEDs exhibited single peaks. However, the red μ LED had a tiny additional peak located in the wavelength range of $460\text{--}480 \text{ nm}$. We presumed that this additional peak was mainly caused by the indium phase separation in high-In-content InGaN QWs [31,32].

The peak wavelengths of the RGB monochromatic μ LEDs exhibited the blueshift as the current density increased in Fig. 3(a). However, the blueshift values from 11.5 to 115 A/cm^2 were quite different for the RGB monochromatic μ LEDs. The blue and green μ LEDs showed a slight blueshift of the peak wavelength within 4 nm . However, the red μ LED had a blueshift of approximately 34 nm from the peak wavelength of 666 nm at 11.5 A/cm^2 to 632 nm at 115 A/cm^2 . This blueshift for the red μ LED is similar to our previous amber μ LEDs [29] and was mainly caused by the strong QCSE in the high-In-content InGaN QWs.

We also extracted and compared the FWHMs of the RGB monochromatic μ LEDs, as shown in Fig. 3(b). The FWHMs at $11.5\text{--}115 \text{ A/cm}^2$ were around $20\text{--}22 \text{ nm}$ for the blue μ LEDs. But this became broader, to $28\text{--}31$ and $72\text{--}81 \text{ nm}$, for the green and red μ LEDs, respectively. This result was reasonable because the In fluctuation would be increased in the high-In-content InGaN QWs. Besides, the FWHMs of the RGB monochromatic μ LEDs became broader as the current density increased, which originated from the generated heat under the high current density operation [31]. The heat was usually generated at the vicinity of defects [33], so the higher defect densities in the red μ LEDs would generate more heat and make the value of FWHM larger compared with the green/blue monochromatic μ LEDs.

The on-wafer LOP density can be used to evaluate the brightness of μ LEDs. Figure 4 shows that the calculated on-wafer LOP density of green μ LEDs is slightly lower than that of blue μ LEDs. However, the LOP density of the red μ LEDs is almost one order of magnitude lower than that of the green/blue μ LEDs at the same current density. Besides, the LOP density of the red μ LEDs decreased faster as the current density decreased when compared with the green/blue μ LEDs. The phenomenon can be explained by the dominant

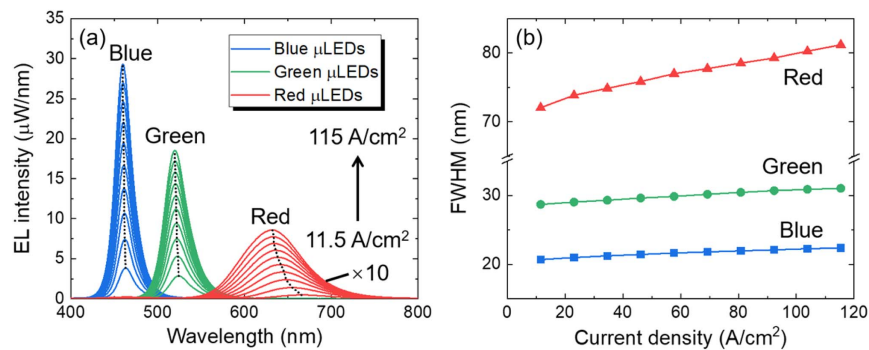


Fig. 3. (a) EL spectra. (b) FWHM of RGB monochromatic μ LEDs at 11.5 to 115 A/cm^2 .

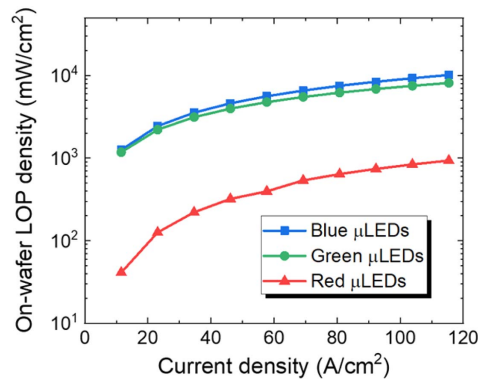


Fig. 4. On-wafer LOP density of RGB monochromatic μ LEDs at different current densities.

Shockley–Read–Hall (SRH) recombination at lower current densities. Compared with green/blue μ LEDs, red μ LEDs have more defects in the active region. These defects serve as the SRH recombination centers and suppress the radiative recombination, especially at the lower current densities [34]. Therefore, less percent of carriers contribute to the light output and result in further reduction of the LOP density for red μ LEDs as the current density decreases.

Because of the lower LOP density, the red μ LEDs require to be operated at a higher current density to achieve a similar brightness to that of the green/blue μ LEDs. Generally, AR head-mounted displays need to achieve very high brightness ($\sim 1 \times 10^5$ cd/m²), which requires the blue μ LEDs operating at ~ 10 A/cm² [21]. To achieve a similar brightness, we estimated that the red μ LEDs should exhibit a similar level of the LOP density to the blue μ LEDs. As a result, we found that red μ LEDs needed to be operated at ~ 115 A/cm² in Fig. 4, one order of magnitude higher than the operated current density for blue μ LEDs (11.5 A/cm² in Fig. 4). Fortunately, even at such a high current density, our red μ LEDs still have a peak wavelength of 632 nm [Fig. 3(a)], which guarantees the emission located at the red region. Therefore, we conclude that our red μ LEDs can satisfy the very high brightness requirement for AR displays.

We also compared the performance of the red μ LEDs with other works [9,11,13,35,36]. As shown in Table 1, the red μ LEDs in this work realized the highest current density at the emission wavelength around 630 nm. As a result, the LOP density of the red μ LEDs reaches approximately 936 mW/cm², which is the highest reported value so far for InGaN-based red μ LEDs.

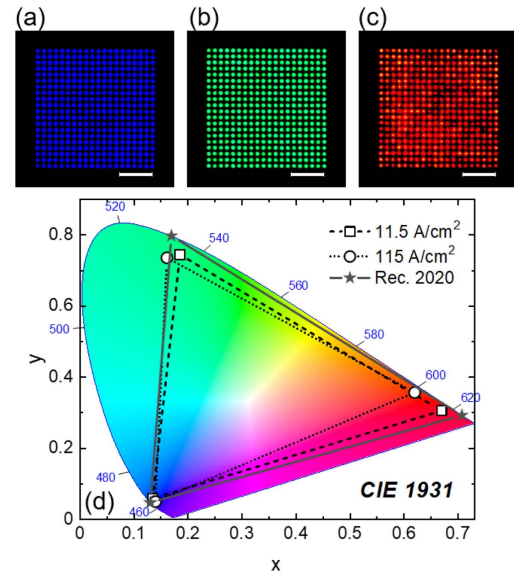


Fig. 5. (a)–(c) EL emission images of RGB monochromatic μ LED arrays at 115 A/cm². The scale bar in the inset is 50 μ m. (d) CIE 1931 diagram of RGB monochromatic μ LED arrays at 11.5 and 115 A/cm².

Figures 5(a)–5(c) show the EL emission images of RGB monochromatic μ LED arrays at 115 A/cm². We adjusted the exposure time for the CCD camera to capture these images. The clear RGB μ LED pixels in these figures imply that the pixelation of the conductive p-GaN in Fig. 1 worked well to realize ultrasmall μ LEDs. Besides, Fig. 5(c) implies that our red μ LEDs at 115 A/cm² look “red,” demonstrating the possibility of our red μ LEDs to work as a “red color” for high brightness requirement. However, compared with the uniform luminescence of green/blue monochromatic μ LED arrays, some bright and dark pixels could be observed for the red μ LED arrays. This luminescence nonuniformity was caused by many defects in the red QWs [26,31], which should be further reduced in the future.

We also calculated the coordinates of RGB monochromatic μ LEDs at 11.5 and 115 A/cm² in the CIE 1931 diagram [Fig. 5(d)]. The primary RGB colors in Rec. 2020 are plotted as stars for comparison. Due to the blueshift of the emission wavelength in Fig. 3(a), the positions in CIE 1931 would move counterclockwise for green and red μ LEDs but almost remain constant for blue μ LEDs. The color gamut by the RGB monochromatic μ LEDs covered 83.7% to 75.9% of the Rec. 2020 color space at 11.5 to 115 A/cm². The coverage values are

Table 1. Comparison of LOP Density for InGaN-Based Red μ LEDs

Affiliation	Peak Wavelength (nm)	Current Density (A/cm ²)	LOP Density (mW/cm ²)
KAUST (this work)	632	115	936
KAUST [13]	626	4	29
KAUST [35]	630	50	176
UCSB [11]	632	10	40
Univ. of Grenoble-Alpes [9]	630	0.8	0.4
Plessey [36]	630	10	—

quite comparable with RGB μ LEDs using quantum dot color converters [37,38].

4. CONCLUSION AND PROSPECT

In summary, here we have demonstrated that the p-GaN was passivated after H_2 -plasma treatment and would form a Schottky contact with the ITO layer, which prevented the current injection into InGaN QWs. We utilized this pixilation method to realize 5 μ m squircle InGaN-based RGB monochromatic μ LEDs and maintained the good distinctiveness of the ultrasmall μ LED pixels. A broader FWHM (72–81 nm) and a larger peak wavelength blueshift from 666 to 632 nm at 11.5–115 A/cm² were observed for the red μ LEDs. The on-wafer LOP density of the red μ LEDs was obtained as 936 mW/cm², which is the highest reported value thus far for InGaN-based red μ LEDs. However, the on-wafer LOP density of the red μ LEDs was still lower than that of green/blue μ LEDs by one order of magnitude, which required higher operation current densities for red μ LEDs to achieve similar brightness. The color gamut based on InGaN RGB monochromatic μ LEDs covered 83.7% and 75.9% of the Rec. 2020 color space in CIE 1931 at 11.5 and 115 A/cm², respectively.

To realize full-color displays, the research group from Samsung Ltd. utilized the pixilation of blue μ LEDs by ion implantation and chose quantum dot color converters for red/green μ LEDs [21]. They avoided the mass transfer process and realized the prototype of micro-displays. In the case of RGB monochromatic μ LEDs, the full-color displays generally need to assemble individual RGB μ LEDs side-by-side via mass transfer. But this integration method is not suitable for the proposed pixilation method in this work. Another approach is vertically stacking the monochromatic μ LED arrays, which was demonstrated by Lee *et al.* for a dual-color μ LED display [39] and by Yadavalli *et al.* for full-color μ LED displays (R: AlGaInP; G and B: InGaN) [40]. Therefore, we can expect that this vertical stacking method can be used for integration of our pixelated RGB monochromatic μ LED arrays for full-color ultrahigh-brightness and ultrahigh-definition displays in the future.

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Disclosures. The authors declare no conflicts of interest.

Data Availability. Data underlying the results presented in this paper are not publicly available at this time but may be obtained from the authors upon reasonable request.

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